

PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
HUI WANG	12/14/2020
ZHIYOU FANG	12/13/2020
JUN WU	12/13/2020
GUANZHONG LU	12/20/2020
FUPING CHEN	12/13/2020
JIAN WANG	12/20/2020
JUN WANG	12/26/2020
DEYUN WANG	12/26/2020
RECEIVING PARTY DATA	
Name:	ACM RESEARCH (SHANGHAI) INC.
Street Address:	BUILDING 4, NO.1690, CAI LUN ROAD
Internal Address:	ZHANGJIANG HIGH-TECH PARK, PUDONG DISTRICT
City:	SHANGHAI
State/Country:	CHINA
Postal Code:	201203
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	16972936
CORRESPONDENCE DATA	
Fax Number:	
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>	
Email:	page@obwbip.com
Correspondent Name:	ARON T. GRIFFITH
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ATTORNEY DOCKET NUMBER:	17433-085001
NAME OF SUBMITTER:	ARON T. GRIFFITH

SIGNATURE:	/ARON T. GRIFFITH/
DATE SIGNED:	02/22/2021
	This document serves as an Oath/Declaration (37 CFR 1.63).
Total Attachments: 2 source=17433-085001 - Assignment#page1.tif source=17433-085001 - Assignment#page2.tif	



DECLARATION AND ASSIGNMENT – WORLDWIDE

Whereas, the undersigned individual(s) (referred to herein as the "INVENTOR(S)") has/have invented:

☐ The attached application to be filed as a United States application or PCT international application, or

☒ United States application or PCT international application number PCT/CN2018/090227 filed on June 7, 2018; and, entitled:

APPARATUS AND METHOD FOR CLEANING SEMICONDUCTOR WAFERS

Regarding that application, each of the INVENTOR(S) declares the following:

- The above-identified application was made or authorized to be made by me.
- I believe that I am the original inventor or an original joint inventor of a claimed invention in the application.
- I hereby acknowledge that any willful false statement made in this declaration is punishable under 18 U.S.C. 1001 by fine or imprisonment of not more than five (5) years, or both.

For good and valuable consideration, the receipt and sufficiency of which are hereby acknowledged, the INVENTOR(S) hereby assign, transfer, and set over to:

ACM Research (Shanghai) Inc.

having the following address:

Building 4, No.1690, Cai Lun Road, Zhangjiang High-Tech Park, Shanghai, P.R. China 201203

(referred to herein as "COMPANY"), its successors, and assigns, the entire right, title, and interest, worldwide, in and to the invention described in the patent application identified above (referred to herein as "INVENTION"), together with said patent application, all divisions, continuations, continuations-in-part, reissues, and extensions thereof, and all Letters Patent (domestic and foreign) that may be granted therefor. Such interest represents the entire ownership of said applications and Letters Patent when granted and is to be owned by COMPANY, its successors, and assigns, or their legal representatives, for the full and entire term for which such Letters Patent may be granted or extended, as fully and entirely as the same would have been enjoyed by the INVENTOR(S) if this assignment had not been made.

In addition, the undersigned INVENTOR(S) each hereby agrees:

1. To sign and execute any further documents that may be necessary or desirable, lawful, and proper in connection with the prosecution of all applications for patent(s) on the INVENTION in the United States, including without limitation said application and all divisions, continuations, continuations-in-part, amendments thereof, and all interference proceedings associated therewith, or otherwise necessary or desirable to secure the title thereto to COMPANY;



2. To execute all papers and documents and to perform all lawful acts that may be necessary in connection with claims to priority or otherwise under the International Convention for the Protection of Industrial Property or similar treaties or agreements;
3. To perform all lawful affirmative acts that may be necessary to obtain the grant of valid and enforceable patents to COMPANY.

The undersigned INVENTOR(S) each hereby authorizes and requests the Commissioner of Patents and Trademarks in the United States to issue any and all Letters Patent resulting from said application, including without limitation any division, continuation, continuation-in-part, or reissue thereof to COMPANY.

The undersigned INVENTOR(S) each hereby grants to the firm of OSHA BERGMAN WATANABE & BURTON LLP the power to insert on this Assignment any further identification that may be necessary or desirable in order to comply with the rules of the United States Patent and Trademark Office for the recordation of this document.

IN WITNESS WHEREOF, this Assignment has been executed by each of the undersigned individuals on the date appearing by such individual's signature:

<u>2020 / 12 / 14</u> Date	1 st Inventor Signature: <u>[Signature]</u> Print or Type Name: <u>WANG, Hui</u>
<u>2020 / 12 / 13</u> Date	2 nd Inventor Signature: <u>[Signature]</u> Print or Type Name: <u>FANG, Zhiyou</u>
<u>2020 / 12 / 13</u> Date	3 rd Inventor Signature: <u>[Signature]</u> Print or Type Name: <u>WU, Jun</u>
<u>2020 / 12 / 20</u> Date	4 th Inventor Signature: <u>[Signature]</u> Print or Type Name: <u>LU, Guanzhong</u>
<u>2020 / 12 / 13</u> Date	5 th Inventor Signature: <u>[Signature]</u> Print or Type Name: <u>CHEN, Fuping</u>
<u>2020 / 12 / 20</u> Date	6 th Inventor Signature: <u>[Signature]</u> Print or Type Name: <u>WANG, Jian</u>
<u>2020 / 12 / 26</u> Date	7 th Inventor Signature: <u>[Signature]</u> Print or Type Name: <u>WANG, Jun</u>
<u>2020 / 12 / 26</u> Date	8 th Inventor Signature: <u>[Signature]</u> Print or Type Name: <u>WANG, Deyun</u>